

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kenji ITOGA, et al.

Serial No.: 09/769,490

Filed: January 26, 2001



: Customer Number: 20277

: Confirmation Number: 5521

: Group Art Unit: 2882

: Examiner: C. Kao

For: X-RAY EXPOSURE APPARATUS, X-RAY EXPOSURE METHOD, X-RAY MASK, X-RAY MIRROR,
SYNCHROTRON RADIATION APPARATUS, SYNCHROTRON RADIATION METHOD AND
SEMICONDUCTOR DEVICE

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.



No additional fee is required.



Applicant is entitled to small entity status under 37 CFR 1.27



Also attached: Petition for Extension of Time (1 month)

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	20	48	0	\$18.00 =	\$0.00
Independent Claims	12	8	4	\$86.00 =	\$344.00
Multiple claims newly presented					\$0.00
Fee for extension of time					\$110.00
					\$0.00
Total of Above Calculations					\$454.00

☒ Please charge my Deposit Account No. 500417 in the amount of \$454.00. An additional copy of this transmittal sheet is submitted herewith.

☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

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